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Attorney's Docket No. 42390.P4222D2

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#6/ Election  
3/5/02  
18

In Re Application of:

Robert S. Chau, et al.

Examiner: TRAN, Thien

U.S. Serial No: 09/654,315

Art Unit: 2811

Filed: September 1, 2000

I hereby certify that this correspondence is being deposited with the United States Patent Service as first class mail with sufficient postage to an address addressed to the Commissioner for Patents, Washington, D.C. 20231

For: DEVICE STRUCTURE AND  
METHOD FOR REDUCING  
SILICIDE ENCROACHMENT

December 3, 2001  
Date of Deposit  
DIANNE NEATHERY  
Name of Person Making Correspondence  
Dianne Neathery  
12/3/01  
2001  
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Commissioner for Patents  
Washington, D.C. 20231

RESPONSE TO ELECTION REQUIREMENT

Dear Sir:

In Response to the Election Requirement mailed November 21, 2001, Applicants hereby elect to prosecute Group I claims, claims 30-37, drawn to a semiconductor device, and withdraw Group II claims, Claims 38-43 drawn to a process for making semiconductor devices.

If there are any additional charges, please charge them to our Deposit Account Number 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: 12/3, 2001

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